GAU-2814\$

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): David Y. Kao, et al.								Docket No. 11675.107		
Serial No.		Filing October		Examiner George Fourson				Group Art Unit 2814		
Invention: OXIDATION OF ION IMPLANTED SEMICONDUCTORS JUL 0 2 1998 JUL 0 2 1998										
TO THE ASSISTANT COMMISSIONER FOR PATRICE LIVED										
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below. DEC 1 5 1998 ECEIVED GROUP 1706 2 7 1998										
CLAIMS AS AMENDED								GHUND 2100		
	CLAIM	IS REMAINING	REMAINING HIGHEST #		NUMBER EXTRA		RATE		ADDITIONAL	
	AFTER	RAMENDMENT	PREV. PAID FOR		CLAIMS P	S PRESENT			FEE	
TOTAL CLAIMS	4	-	42	=		2	×	\$22.00		
INDEP. CLAIMS	<u> </u>	6 -		=		0	X	\$82.00		
Multiple Dependent Claims (check if applicable) \$0.00 TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$44.00										
 No additional fee is required for amendment. Please charge Deposit Account No. in the amount of A duplicate copy of this sheet is enclosed. ✓ A check in the amount of \$44.00 to cover the filing fee is enclosed. ✓ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 23-3178 A duplicate copy of this sheet is enclosed. ✓ Any additional filing fees required under 37 C.F.R. 1.16. ✓ Any patent application processing fees under 37 CFR 1.17. Dated: June 19, 1998 GROUP 2100 Bradley K. DeSandro, Reg. No. 34,521 WORKMAN, NYDEGGER & SEELEY CENED 										
1000 Eagle Gate 60 East South To Salt Lake City, 1	emple	111 GF 0082 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7	ECEIVED MAR 0 4 1999 ROUP 170 MINIO APPROVE	00° 		on June 19, first class m Assistant C 20231.	1998 ail unc commis	der 37 C.F ssioner for of Person	nt and fee is being deposited with the U.S. Postal Service as F.R. 1.8 and is addressed to the property of Patents, Washington, D.C. Mailing Correspondence Freedman	

JUN 2 2 1999 20 DE THE LIN

PATENT APPLICATION
Docket No: 11613.107

Group Art Unit

1.19

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GROUP 2100

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

David Y. Kao, et al.

Serial No.:

08/720,693

Filed:

October 2, 1996

For:

OXIDATION OF ION IMPLANTED

SEMICONDUCTORS

RECEIVED

DEC 1 5 1998

Examiner:

George Fourson

GROUP 1700

AMENDMENT A UNDER 35 U.S.C. § 1.115

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

IN THE SPECIFICATION

Page 14, line 19: change " 4 " to --7 --;

Page 17, line 11 and Page 23, line 2: Check

change "charge characteristic" to -- conductivity type --;

Page 25, line 15: change "17" to -- 15 --.

IN THE Claims

In the claims, please amend Claims 1-33 as follows:

06/29/1998 SSANDARA 00000008 08720693

01 FC:103

44.00 OP

24 C W C L L 255

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04/07/2000 AFORD1 00000004 233:78 08720693

01 FC:115

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GROUP 2100

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GROUP 1700